Electronic Acknowledgement Receipt				
EFS ID:	2191818			
Application Number:	10690507			
International Application Number:				
Confirmation Number:	6043			
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing			
First Named Inventor/Applicant Name:	Ji Yong Park			
Customer Number:	49455			
Filer:	Hung H. Bui/Karen Jones			
Filer Authorized By:	Hung H. Bui			
Attorney Docket Number:	1514.1032			
Receipt Date:	13-SEP-2007			
Filing Date:	23-OCT-2003			
Time Stamp:	13:38:22			
Application Type:	Utility under 35 USC 111(a)			

# Payment information:

Submitted with Payment	no
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# File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
,		AmendFiled-09-13-2007.pdf	1109584	yes	11
'			5o49ad8e48e8170890391od7576bdce3 67347bl0		

	Multipart Description/PDF files in .zip description				
	Document Description	Start	End		
	Fee Worksheet (PTO-06)	1	1		
	Amendment - After Non-Final Rejection	2	2		
	Specification	3	3		
	Claims	4	6		
	Applicant Arguments/Remarks Made in an Amendment	7	11		
Warnings:					
Information:					

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Total Files Size (in bytes):

1109584

#### New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.

## New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.